Highly sensitive palladium oxide thin film extended gate FETs as pH sensor

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\textbf{A B S T R A C T}

It is well-known that palladium readily absorbs hydrogen gas at room temperature. Based on this unique property of palladium, palladium oxide (PdO)-sensitive membrane in the extended gate field-effect transistor (EGFET) configurations have been evaluated as a detector for hydrogen ions in pH buffer solutions. The PdO thin film was prepared by a two-step process through reactive electron beam evaporation and subsequent thermal oxidation in an optimal O\textsubscript{2} flow. Our results indicate that the PdO-based EGFET sensor showed super-Nernstian sensitivity approximately 62.87 mV/pH, while exhibiting good linearity as well as good stability between pH 2 and pH 12. Our research demonstrates that PdO membrane can be used in EGFET structure without compromising sensitivity achieved by conventional methods. Furthermore, the disposable PdO sensor shows great potential for low cost biochemical detection due to its simplified fabrication and measurement system.

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1. Introduction

The detection of ions and molecules in a biochemical environment plays a significant role in chemical science and biotechnological application. The basis of an ion-sensitive field-effect transistor (ISFET) is derived from a metal-oxide semiconductor field-effect transistor (MOSFET), of which the metal gate is hereby substituted by an ion-sensitive membrane with direct contact with a buffer solution [1]. Since the invention of the first ISFET by Bergveld in 1970 [2], various techniques and sensing membranes have been exploited. The potential of these solid-state devices has attracted a great deal of attention, due to their numerous advantages such as miniaturization, chip-circuit design and low cost in manufacturing. In particular, they are an excellent candidate for the integration of biochemical sensors in microelectronics. Several ISFET-based biochemical sensors have been proposed [3,4]. However, owing to the fragile nature of membrane degradation in extreme conditions, extended gate field-effect transistor (EGFET) configuration has been developed to prolong stable operation. The mechanism of surface ion adsorption in ISFET and EGFET are essentially the same, with the major difference that EGFET configuration can only be used in low impedance membranes. EGFET is a subset of the ISFET family line, which modifies the ISFET into a two-part design. The sensing membrane is immersed in the solution, while connected to a remote FET IC chip for real-time analysis [1,5,6]. This approach enables us to swap the sensing membrane from any chemical damage instead of fabricating a whole new device.

Prompted by the demand for low cost chemical sensors, researchers looked into SiO\textsubscript{2} initially for pH sensitive membrane. The search for a more compatible material continued as sensitivity and stability impacted the performance of these chips. Since the realization of Ta\textsubscript{2}O\textsubscript{5} as a pH-sensing membrane in 1981 by Matsuo et al. [7], various research groups have demonstrated the use of different sensing membranes such as Al\textsubscript{2}O\textsubscript{3} [8], Si\textsubscript{3}N\textsubscript{4} [4], SnO\textsubscript{2} [9], Eu\textsubscript{2}O\textsubscript{3} [10], Si nanowire/SiO\textsubscript{2}/Al\textsubscript{2}O\textsubscript{3} [11], IrO\textsubscript{2} [12], Gd\textsubscript{2}O\textsubscript{3}/SiO\textsubscript{2} stacked oxide [13], silicon nanowire [14], Ru-doped TiO\textsubscript{2} [15] film in order to enhance detection capabilities. As the Nernst limit of pH sensitivity is 59 mV/pH, “super-Nernstian” sensitivity >59 mV/pH could promise a far more precise detection in monitoring the pH levels in blood and extracellular fluids.

In the 1980s, both Grubb and King [16] and Liu et al. [17] demonstrated the use of palladium–palladium oxide as a wire form electrode for their sensor fabrication. Both fabricated sensors revealed merits in pH detection, with the exception reported by...
Liu et al., for exceeding Nernstian behavior with 71.4 ± 5 mV/pH. Grubb and King employed high temperature thermal oxidation of the palladium wire, whereas Liu et al. used electrochemical anodization. This was followed by the works of Kinoshita et al. [18] and Bloor et al. [19], whose groups also fabricated Pd–PdO pH electrode via thermal oxidation and electrochemical route respectively. Then in 1986, Karagounis et al. [20] demonstrated the possibility of fabricating Pd–PdO thin film potentiometric pH sensor through RF reactive sputtering technique, reaching a pH sensitivity of 54 mV/pH in the pH range between 3 and 9.

Despite the promising developments in biochemical sensors, Pd–PdO-based sensors in EGFET configurations have not yet been reported. Therefore in this investigation, we propose a highly sensitive membrane consisting of PdO thin film as a pH sensor in the EGFET format. The sensor’s performances in sensitivity, stability and reversibility were measured and analyzed. The experimental results have demonstrated that super-Nernstian pH response was reached with similar sensitivities achieved by conventional methods. These findings demonstrate a novel and effective design of a biochemical sensor by unifying the compound semiconductor sensing membrane with the silicon integrated chip technology.

2. Experimental details

2.1. PdO film preparation

Extended gate field-effect transistors, comprised of PdO thin film sensing membranes were fabricated on sapphire substrate and encapsulated on a copper clad FR-4 printed circuit board (PCB) laminate sheet. To begin with, 130 nm thickness of palladium oxide film was deposited by reactive electron beam (E-Beam) evaporation from a 99.999% pure Pd slug on a two inch sapphire substrate under O3 flow of 20 sccm. The PdO thin film on sapphire then underwent an annealing in furnace at 973 K for an hour in O3 flow of 1 slm. The two-step process was employed for the enhanced formation of PdO film. Morphology analysis was done using field emission scanning electron microscopy (FE-SEM). In addition, X-ray photoelectron spectroscopy (XPS) study was employed to characterize palladium–oxygen species on the surface of PdO film. Analysis through Hall measurement revealed the p-type semiconductive nature of PdO film with sheet resistivity, sheet carrier concentration and mobility of about 1221 Ω/□, 5.93 × 10¹⁴ cm⁻² and 8.61 cm² V⁻¹ s⁻¹ respectively.

2.2. PdO sensor chip fabrication

Copper Clad FR-4 – PCB laminate sheet was first etched to fabricate a mounting template for the sensor chip as shown in Fig. 1(a). Samples of 1 × 1 cm² size were scribed from the native wafer for sensor chip fabrication. For pH detection studies, 1 × 1 cm² PdO/sapphire sample was mounted on square shaped area and bonded via silver paste. Silver paste was then applied carefully in the surrounding edges of the PdO layer and extended to copper plate, as to form the conductive line between sensing membrane and PCB. A homemade epoxy package was employed to encapsulate sensor chip and copper line while exposing a sensing area of approximately 0.25 cm² free from epoxy. The completed sensor as shown in Fig. 1(b) chip was immersed in pH 7 buffer solution for 24 h, allowing sensing surface to stabilize prior to current–voltage (I–V) measurement. A Texas Instruments n-MOSFET CD4007UBE was used as the FET in the EGFET device. The dimension n-MOSFET used for our measurement consists of gate length and gate width of 10 µm and 30 µm, respectively. We have used signal line of coaxial cable to connect copper metal line of fabricated PdO sensor chip and the gate of n-MOSFET as shown in Fig. 1(c). Fig. 1(d) shows the schematic diagram of completed PdO pH sensor chip.

2.3. Measurement of sensor chip

All current–voltage measurements took place in a shielding box in order to prevent any light exposure or electromagnetic
interference. Variation in the solution temperature also can affect the sensor sensitivity as Nernst law is proportional to temperature.

We have performed all the measurement of PdO sensor in room temperature (300 ± 2 K). Buffer solutions of pH 2, 4, 6, 8, 10 and 12 were obtained from Merck Chemicals. The pH-sensing properties in terms of sensitivity, linearity, hysteresis, drift were measured in various pH buffer solutions through Ag/AgCl reference electrode by Agilent B1500A semiconductor parameter analyzer. Fig. 1(e) shows the schematic diagram of the I–V measurement setup for PdO EGFET pH sensor.

3. Results and discussion

3.1. PdO film characterizations

Fig. 2(a) shows the top-view FE-SEM images of the surface morphology of PdO film, which suggests a relatively smooth surface of the film. The XPS spectrum of PdO film is presented in Fig. 2(b) and (c). The Pd 3d₅/₂ and Pd 3d₇/₂ doublet binding energy situated at 336.6 eV and 342.0 eV (Fig. 2(b)) respectively corresponds to the chemical state of PdO. The binding energy peak of the O 1s situated at 529.8 eV and the Pd 3p₃/₂ signal situated at 533.7 eV (Fig. 2(c)) which also correspond to the chemical state of PdO. The binding energy peaks determined are in agreement with that previously reported values for palladium oxide [21]. Taken together, it is verified that the formation of PdO layer during the combined process of reactive EB deposition in O₂ flow and furnace annealing process in O₂ ambient.

Analysis on PdO membrane’s pH sensitivity, linearity, real-time response, hysteresis and drift were examined in order to determine its sensing characteristics.

Fig. 2. (a) Surface morphology of PdO film by FE-SEM (×2.2 K), X-ray photoelectron spectra showing binding energy of (b) Pd 3d₅/₂, Pd 3d₇/₂ and (c) O 1s, Pd 3p₃/₂ core level electrons of PdO film.

Fig. 3. (a) Transfer characteristics (I_DS–V_REF) for the PdO ion-sensitive EGFET sensor in the linear regime for different pH values from 2 to 12. (b) Linearity of PdO EGFET sensor in linear region.

3.2. Sensitivity and linearity (linear region)

In accordance to the EGFET theory, the relationship between I_DS vs. V_REF in the linear region can be expressed as follows:

\[ I_{DS} = \frac{W \mu_n C_{ox}}{2L} [2(V_{REF} - V_{T(EGFET)})V_{DS} - V_{DS}^2] \]  

(1)

where \(W/L\) denotes the channel width to length ratio, \(\mu_n\) denotes the electron mobility in the channel, \(C_{ox}\) denotes the gate capacitance per unit area, \(V_{T(EGFET)}\) denotes the threshold voltage of EGFET sensor, \(V_{REF}\) and \(V_{DS}\) are the reference and the drain-source voltages. The \(V_{T(EGFET)}\) could be expressed in the following formula [15],

\[ V_{T(EGFET)} = V_{T(MOSFET)} - \frac{\phi_M}{q} + E_{REF} + \chi_{Sol} - \psi \]  

(2)

where \(V_{T(MOSFET)}\) is the threshold voltage of MOSFET, \(\phi_M\) is the work function of the metal gate (reference electrode) relative to the vacuum, \(E_{REF}\) is the potential of the reference electrode, \(\chi_{Sol}\) is the surface dipole potential of the buffer solution, and \(\psi\) is the surface potential at the electrolyte/sensing film interface.

The \(I_{DS}–V_{REF}\) characteristics are shown in Fig. 3(a) for PdO EGFET sensors in the linear region. The \(I_{DS}–V_{REF}\) curve in linear region shows a uniform shift of the threshold voltage to higher voltage with the decreasing concentration of the hydrogen ions, i.e., the threshold voltages shifts from the left to the right as the hydrogen ions concentration decreased. The pH sensitivity and linearity of the PdO film was derived from the \(I_{DS}–V_{REF}\) curves at \(I_{DS} = 100 \mu A\) in pH solutions ranging from pH 2 to pH 12 as shown in Fig. 3(b).
The pH voltage sensitivity and linearity can then be extracted as follows,

\[
pH\text{ voltage sensitivity } = \frac{V_{\text{EGFET}}(x_2) - V_{\text{EGFET}}(x_1)}{\text{pH}(x_2) - \text{pH}(x_1)} \tag{3}
\]

\[
= \frac{\Delta V_{\text{EGFET}}}{\Delta \text{pH}}
\]

The sensitivity of the PdO EGFET sensor was calculated to be 62.87 mV/pH and linearity was revealed to be 99.97%. These results have demonstrated that the PdO sensor membrane exhibits a linear pH change. We have measured five different PdO sensor chip prepared in different batches. The sensitivity values in pH range from 2 to 12 are found to be 60.38, 60.43, 61.60, 62.87, 65.31 mV/pH. All of the sensor chips have shown sensitivity greater than 59 mV/pH. The average sensitivity is 62.11 mV/pH. The calculated standard deviation is 2.05. We have presented data from the sensor chip of sensitivity 62.87 mV/pH which is close to the calculated average sensitivity. Considering a maximum Nernst response of 59 mV/pH at 293 K, an error of 1 K leads to 0.2 mV/pH which results a variation of ±0.4 mV/pH in sensor output in room temperature (300 ± 2 K). Therefore, temperature effect on sensor output is within experimental error and negligible. In comparison, the super-Nernstian sensitivity achieved in our PdO EGFET sensor is higher than the previously reported sensitivity for PdO thin film [20]. Recently, super-Nernstian response was achieved through double gate MOSFET configuration [22,23]. The capacitive coupling between its bottom gate and top gate can be controlled so that any higher desired super-Nernstian sensitivity of over 59 mV/pH can be attained via a well optimized design of bottom gate and top gate. This certainly does not apply to our PdO EGFET system, as we have opted for an easier configuration. Super-Nernstian response achieved in several reported articles, including our observation does not violate the concept of ‘Nernst Law’ or ‘Site Binding Model for insulator-electrolyte interface’, rather it is an exception of the ‘Nernst Law’ and ‘Site Binding Model’. The super-Nernstian could be related to the enhanced proton-exchange process [24] due to the increased oxidation state of PdO metal-oxide. The difference in fabrication conditions lead to different oxidation states of the metal-oxide thin film as higher oxidation states resulted in higher sensitivity [25]. Ultimately we believe that the enhanced PdO formation through two-step oxidation (reactive E-beam and furnace annealing in optimal \(O_2\) flow) could be responsible for the super-Nernstian pH response in our study.

3.3. Sensitivity and linearity (saturation region)

Saturation occurs when a channel has been created, allowing current to flow between the drain and source. With different amounts of \(H^+\) ions accumulated on the surface in response to the pH buffer solution, saturation sensitivity and linearity can be derived from the \(I_{DS}-V_{DS}\) curves in buffer solutions ranging from pH 2 to pH 12. Fig. 4(a) demonstrated the \(I_{DS}-V_{DS}\) characteristics of PdO sensor in pH = 2 to 12 when MOSFET was operating in the saturation region at \(V_{REF}\) of 2 V. It shows that the \(I_{DS}-V_{DS}\) curve shifts downward with an increase in pH values. For the saturation region of the PdO EGFET, the \(I_{DS}-V_{DS}\) can be expressed as

\[
I_{DS} = \frac{W_{\text{gate}}}{2L} [(V_{\text{REF}} - V_{\text{EGFET}})^2] \tag{4}
\]

The pH current sensitivity can be expressed as follows,

\[
pH\text{ current sensitivity } = \frac{\sqrt{I_{DS}(y_2)} - \sqrt{I_{DS}(y_1)}}{\text{pH}(y_2) - \text{pH}(y_1)} = \frac{\Delta \sqrt{I_{DS}}}{\Delta \text{pH}} \tag{5}
\]

The derived pH current sensitivity was approximately 1.08 (\(\mu A\))\(^{1/2}\)/pH which is also notably high, with a linearity of 99.92%

![Fig. 4. Output characteristics (\(I_{DS}-V_{DS}\)) for the pH-EGFET sensors in the saturation regime for different pH values from 2 to 12. (b) Linearity of the \(I_{DS}\) of PdO EGFET sensor in saturation region.](image)

3.4. Stability and reliability

Moreover, the stability of the device was investigated. For real-time response, we have used program in Agilent Easy Expert Software that monitored the drain current as a function of time, while keeping the drain bias (\(V_D\)) and gate bias (\(V_G\)) constant. Fig. 5 shows the real-time responses of \(I_{DS}\) for PdO sensor chip dipped as shown in Fig. 4(b). The result is an indication that \(\sqrt{I_{DS}}\) linearly depends on the pH value in the saturation region.

![Fig. 5. Real-time \(I_{DS}\) responses of PdO sensor in a pH loop of 2 → 12 → 2 at \(V_{REF}\) of 2 V.](image)
for 60 s in each buffer solution of different pH values (pH loop: 2 → 12 → 2) at a $V_{REF}$ of 2 V and $V_D = 100$ mV. The cyclic step determines the accuracy of the sensor within a period of 660 s. It is a real-time exhibition of reliability, such that the $I_{DS}$ decreases linearly as the pH value increases and vice versa. As shown in this figure, the fabricated PdO EGFET has exhibited almost perfect symmetric response together with low hysteresis due to the buffer solution variations.

Fig. 6 shows the hysteresis effect of the PdO sensing membrane. Hysteresis is known to be related to chemical interaction between ions in an electrolyte and slow reacting surface-sites underneath the membrane surface and/or the surface defects of the membrane [26]. For hysteresis characteristic, we have measured a family of $I_D$–$V_C$ curves for each pH value when PdO sensing membrane was immersed in alternating cycles of pH buffer solution (i.e. pH 7 → pH 4 → pH 7 → pH 10 → pH 7 for 5 min in each pH buffer solution. Next, the reference bias voltage for a fixed drain current of 100 μA were extracted from each curve and plotted with different pH values. The net hysteresis was calculated as a difference between the initial reference voltage and final reference voltage at pH 7 to be 7.9 mV. In addition, drift in the reference voltage or threshold voltage of EGFET was studied for long-term reliability of electrochemical sensors which relates to OH$^-$ adsorption on sensing film surface at different buffer solutions [27]. The potential drift phenomenon is common in ion selective pH sensors and the 3–10 mV drift is considered small [28]. In this work, the drift of the PdO sensor was measured in pH 7 buffer solution for 12 h. The drift property is compared by calculating the drift rate, $\Delta V_{REF}$/h. For drift characteristic, we also measured a family of $I_D$–$V_C$ curve in pH 7 for 12 h for long-term drift measurement. Similarly, the reference bias voltage for fixed drain current of 100 μA were extracted from each curve and plotted with time. Our PdO pH sensor drift was characterized by initial drift of 7.4 mV and long-term drift rate of 2.32 mV/h as shown in Fig. 7. As threshold voltage shifted toward positive direction during drift measurement, therefore it is believed that initial fast drift may be caused by OH$^-$ ion adsorption in PdO sensing surface site and remaining lower long-term drift caused by slow diffusion of OH$^-$ in slowly reacting buried site of PdO film. When compared to our result, lower drift of 0.38 mV/h and 0.3 ± 0.1 mV/h were achieved in ruthenium oxide [29] and iridium oxide [29] metal-oxide pH sensors. Nonetheless our PdO film has lower long-term drift rate compared to other reported result on SnO$_2$ [30], a-WO$_3$ [31] sensing membrane.

As the sensor suffers damage after being immersed in solution, from the experimental observation, we would like to mention that the PdO sensor chip we have fabricated has shown good sensing properties in terms of sensitivity and linearity for 6–7 complete cycles (pH 2 → pH 12 → pH 2) of measurements in the pH range from 2 to 12. After that sensitivity and linearity properties degrade with no such visual degradation on the PdO surface.

4. Conclusions

In this study, we have reintroduced the PdO thin film based sensor via EGFET technique. Top-view FE-SEM image has suggested a relatively smooth surface morphology of PdO film prepared through a two-step process. Material analysis with XPS confirmed the chemical state of PdO through Pd 3d$_{5/2}$ and Pd 3d$_{3/2}$ doublet, Pd 3p$_{3/2}$ and O 1 s binding energy peak positions. The fabricated PdO sensor seemed suitable for pH sensing, as super-Nernstian sensitivity of 62.87 ± 2 mV/pH, linearity of 99.97%, low hysteresis of 7.9 mV and drift rate of 2.32 mV/h were achieved. The sensitivity and linearity (both in linear and saturation regime), reversibility, hysteresis effect, and drift analysis have indicated the sensor chip to be reasonably accurate, stable and reliable in pH testing. As a result, the performance of a PdO-based sensor in EGFET configuration not only benefits disposability in replacing damaged sensing membranes, but also maintaining an adequate pH-sensing standard. Thus, palladium oxide based EGFET shows great promise in biochemical sensing applications.

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References

Biographies

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